

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Tsuyoshi YOSHITAKE**

Application Number: **Not yet assigned**
(§371 of international application No. PCT/JP2004/011543)

Filed: **April 7, 2006**

For: **FILM DEPOSITION APPARATUS HAVING HOLE-LIKE ROTARY
FILTER PLATE FOR CAPTURING FINE PARTICLES, AND FILM
DEPOSITION METHOD**

Attorney Docket Number: **062186**
Customer Number: **38834**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

April 7, 2006

Sir:

In compliance with 37 C.F.R. §1.56, Applicant directs the attention of the Patent and Trademark Office to the documents listed on the attached PTO/SB/08. A copy of each non- U.S. document is enclosed herewith as well as an International Search Report mailed November 22, 2004.

If there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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Enclosure: PTO/SB/08, Documents (13) & Int'l Search Report

IA99 Rec'd PCT/PTO 07 APR 2006
Complete if Known

Combined Form PTO/SB/08A&B				Application Number		Not yet assigned	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Confirmation Number			
				Filing Date		April 7, 2006	
				First Named Inventor		Tsuyoshi YOSHITAKE	
				Art Unit			
				Examiner Name			
Sheet		1		of		1	
				Attorney Docket Number		062186	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
		US			
		US			
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FOREIGN PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁴
		Country Code ²	Number ³	Kind Code ² (if known)			
	1	JP	2003-49262		2/21/2003	Japan Science & Technology Corp	Abstract
	2	JP	10-30169		2/3/1998	Mitsubishi Materials Corp	Abstract
	3	JP	2003-277919		10/2/2003	Toyota Central Res & Dev Lab Inc	Abstract
	4	JP	2003-73812		3/12/2003	Yamamoto Masaki and Mitsubishi Precision Co Ltd	Abstract
	5	JP	6-17237		1/25/1994	Toyota Motor Corp et al.	Abstract
	6	JP	7-166331		6/27/1995	Ko Ensei	Abstract
	7	JP	2001-107225		4/17/2001	Japan Science & Technology Corp	Abstract
	8	JP	8-176805		7/9/1996	Minolta Co Ltd	Abstract
	9	JP	4-202762		7/23/1992	Hoya Corp and Murakami Koichi	Abstract
	10	JP	10-30168		2/3/1998	Mitsubishi Materials Corp	Abstract
	11	JP	2001-192811		7/17/2001	Canon Inc	Abstract

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.			Translation ⁴
	12	TSUYOSHI YOSHITAKE et al., "Droplet-Free Thin Films Prepared by Pulsed Laser Deposition...", Jpn.J.Appl.Phys. Vol. 41 (2002) pp.836-837			
	13	E.V. PECHEN et al., "Pulsed-laser deposition of smooth high-T _c superconducting films using...", Appl.Phys.Lett. 1995 Vol. 66, No. 17, pp. 2292-2294			
	14	International Search Report of International Application PCT/JP2004/011543 mailed November 22, 2004			

Examiner Signature	/Shamim Ahmed/ (06/09/2009)	Date Considered	06/09/2009
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